IN THE UNITED STATES PATENT AND TRADEMARK OFFICE IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

(pplicant:

L.M. Nicholson et al.

Title:

Improved Chemical Planarization Performance for Copper/Low-k

Interconnect Structures

Filed:

July 28, 2003

Serial No.:

10/628,925 Nitin Parekh

Examiner: Art Unit:

2811

Docket No.:

YOR920030173US1

Customer No.: 22032

Confirmation No.:

7501

Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT TRANSMITTAL FORM

Sir:

Transmitted herewith is Response to the Restriction Requirement dated September 17, 2004 in the above-identified application.

Request for extension of time pursuant to 37 C.F.R. §§ 1.136 and 1.137 is
hereby made if, and to the extent, required. The fee for this extension of time is
calculated to be \$ to extend the time for filing this response until
The fee for any change in number of claims has been calculated as shown below

	Claims Remaining After Amendment		Highest Number Previously Paid	Present Extra	Rate	
Total Claims	50	Minus	50	0	x \$18.00	
Independent Claims	2	Minus	3	0	x \$84.00	
	IPLE DEPENDEN	CLAIM FEE			<u></u>	x \$280.00 = \$

The total fee for this amendmentime is calculated to be \$0_; ache		ding claim changes, and any extension of is included.					
sheets of amended drawings are enclosed;							
XXX The Commissioner is hereby authorized to charge the amount of and any additional fees under 37 C.F.R. §§1.16 and 1.17 which may be required with this communication or during the entire pendency of the application, or credit any overpayment, to Deposit Account No. 50-0510.							
A duplicate copy of this Form is enclosed.							
		Respectfully submitted,					
October 15, 2004 Date	By:	Vazken A. Alexanian Agent for Applicant(s) Registration No. 37,270 Ohlandt, Greeley, Ruggiero & Perle, L.L.P. One Landmark Square, 10th Floor Stamford, Connecticut 06901-2682 U.S.A. Telephone: (203) 327- 4500 Telefax: (203) 327- 6401					
CERTIFICATE OF MAILING							
I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on October 15, 2004.							
Vazken Alexanian NAME		NATURE DATE					



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Sir:

RESPONSE TO RESTRICTION REQUIREMENT

In response to the Restriction Requirement dated September 17, 2004, applicants elect as follows:

Applicants hereby elect for further prosecution the claims of Group I (1-31) drawn to an electrical interconnect structure, classified in class 257, subclass 760.

This election is made with traverse.

Applicants respectfully submit that a search relating to an electrical interconnect structure will necessarily produce art relating to a method of preparing the electrical interconnect structure.

Thus, the Restriction Requirement should be withdrawn and both Group I and Group II should be examined because examination of the claims of Group I and Group II, i.e., electrical interconnect structure and method of preparing the electrical interconnect structure, would not be burdensome.

Applicants respectfully request examination of this application and allowance of the pending claims.

Respectfully submitted,

Date: October 15, 2004

By:

Vazken A. Alexanian
Agent for Applicant(s)
Registration No. 37,270
Ohlandt, Greeley, Ruggiero
& Perle, L.L.P.

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